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DEC 29 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen  
Appl. No.: 09/898,439  
Confirm. No.: 1885  
Filed: July 5, 2001  
Title: PLASMA SEMICONDUCTOR PROCESSING  
SYSTEM AND METHOD

## PATENT APPLICATION

Art Unit: 2818  
Examiner: Quoc Dinh Hoang  
Customer No. 23910

## CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 29, 2005.

Sheldon R. Meyer

Signature Date: December 29, 2005

(Signature)

## REPLY TO FINAL OFFICE ACTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a response to the Office Action mailed July 29, 2005, setting a period for response expiring on October 29, 2005. A Petition for Extension of Time is being submitted herewith to extend the response period to December 29, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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